

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Woo Young SO, et al.

Application No.: Unassigned

Group Art Unit: Unassigned

Filed: February 8, 2002

Examiner: Unassigned

For: THIN FILM TRANSISTOR AND MANUFACTURING METHOD THEREOF, AND ACTIVE MATRIX DISPLAY DEVICE AND MANUFACTURING METHOD THEREOF

**SUBMISSION TO CLAIM THE BENEFIT TO THE PRIORITY  
OF PRIOR FOREIGN APPLICATION**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicant(s) respectfully claim the benefit to the priority of prior foreign application in accordance with the provisions of 37 C.F.R. § 1.55, and submit that a certified copy of the following foreign application will follow:

Korean Patent Application No. 2001-10842

Filed: March 2, 2001

It is respectfully requested that the applicant(s) be given the benefit of the foreign filing date(s) as will be evidenced by the certified papers to follow, in accordance with the requirements of 35 U.S.C. § 119.

Respectfully submitted,  
STAAS & HALSEY LLP

Date: 2/8/02

By: 

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